

U.S. Department of Commerce, Patent and Trademark Office					Atty Docket No.		Serial No.	
					M-8873 US			
INFORMATION DISCLOSURE STATEMENT BY APPLICANT					Applicant(s): Steven Z. Wu; Deborra			
(Use several sheets if necessary)					Sanders-Millare; Sameer Harish; Ryan J. PTO			
					Santos; Li Chen			
					Filing Date:		Group	
					October 23, 2000			

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 09/695022

U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<i>PBP</i> 	AA	5,425,739	06/20/95	Jessen	606	155	12/17/92
	AB	5,464,650	11/07/95	Berg et al.	427	2.30	04/26/93
	AC	5,605,696	02/25/97	Eury et al.	424	423	03/30/95
	AD	5,700,286	12/23/97	Tartaglia et al.	623	1	08/22/96
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
AK							

Foreign Patent Documents								
							Translation	
		Document	Date	Country	Class	Subclass	Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)		
<i>PBP</i>	AQ	Microtruder Technology Bulletin; www.randcastle.com ; 03/14/2000; 8 pages.
	AR	

Examiner <i>Paul Prebille</i>	Date Considered <i>12-16-01</i>
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.